

JC Rec'd PCT/PTO 06 MAR 2002

219289US-0PCT

#9.6 (12)
1-14-03
GB
1-14-03
A.B.IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

YASUTAKA ITO ET AL :

ATTN: APPLICATION DIVISION

SERIAL NO: NEW U.S. PCT APPLN :

(Based on PCT/JP00/03041)

FILED: HEREWITH :

FOR: CARBON-CONTAINING ALUMINIUM:
NITRIDE SINTERED BODY, AND
CERAMIC SUBSTRATE FOR A
SEMICONDUCTOR PRODUCING/
EXAMINING DEVICEPRELIMINARY AMENDMENTASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Prior to examination on the merits, please amend the above-identified application as follows.

IN THE TITLE

Please replace the title on page 1, lines 3-5 with the following title.

CARBON-CONTAINING ALUMINIUM NITRIDE SINTERED COMPACT

AND CERAMIC SUBSTRATE FOR USE IN EQUIPMENT

FOR MANUFACTURING OR INSPECTING SEMICONDUCTOR